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Bib Data Sheet

CONFIRMATION NO. 4154

<b>SERIAL NUMBER</b> 09/833,766	<b>FILING DATE</b> 04/13/2001 <b>RULE</b>	<b>CLASS</b> <u>029</u> <u>700</u>	<b>GROUP ART UNIT</b> <u>3729</u> <u>2125</u>	<b>ATTORNEY DOCKET NO.</b> 862.C2199
<b>APPLICANTS</b> Keiji Emoto, Kanagawa, JAPAN;				
** CONTINUING DATA *****				
** FOREIGN APPLICATIONS ***** JAPAN 2000-112216 04/13/2000				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/06/2001				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 8	<b>TOTAL CLAIMS</b> 25
Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>		<b>INDEPENDENT CLAIMS</b> 2		
<b>ADDRESS</b> 05514				
<b>TITLE</b> Pipe structure, alignment apparatus, electron beam lithography apparatus, exposure apparatus, exposure apparatus maintenance method, semiconductor device manufacturing method, and semiconductor manufacturing factory				
<b>FILING FEE RECEIVED</b> 930	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	